

RCE/2881
JAW**REQUEST FOR CONTINUED EXAMINATION
UNDER 37 CFR 1.114**

Applicant(s) : Shin-ichi Hashimoto et al.
App. No. : 10/672,469
Filed : September 26, 2003
For : ELECTRON BEAM EXPOSURE APPARATUS, DEFLECTION APPARATUS,
AND ELECTRON BEAM EXPOSURE METHOD
Examiner : Anthony G. Quash
Art Unit : 2881

**Commissioner for Patents
Alexandria, VA 22313-1450**

This is a request for continued examination under 37 CFR 1.114 in the above-identified utility patent application.

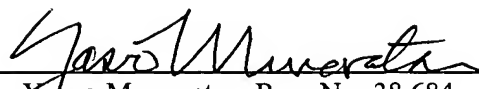
Enclosed:

- (X) An amendment in twelve (12) pages in response to the office action dated October 5, 2004 which is a bona fide attempt to advance the application.
- (X) A check in the amount of \$878.00 for RCE fee and one (1) excess independent claim fee (cause by the amendment in the claims concurrently submitted herewith) is enclosed.
- (X) Return prepaid postcard.

I hereby certify that this correspondence and all marked attachments are being deposited with the United States Postal Service as first class mail in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on

November 22, 2004

(Date)


Yasuo Muramatsu, Reg. No. 38,684

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01 FC:1801
02 FC:1201

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Muramatsu & Associates
7700 Irvine Center Drive
Suite 225, Irvine, CA 92618
(949) 753-1127